

er No.: 14225-027001

Αμμίcant(s): Yusuke Igarashi et al.
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FIG.1

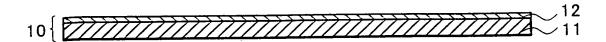


FIG.2

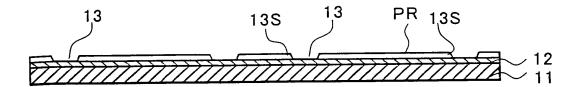
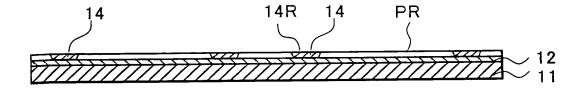


FIG.3



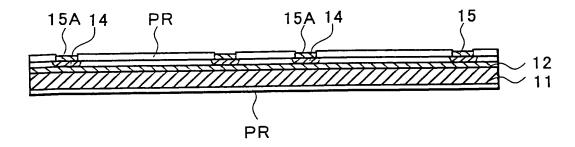


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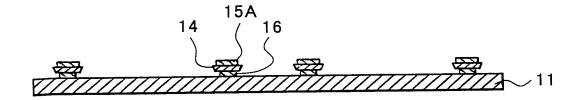
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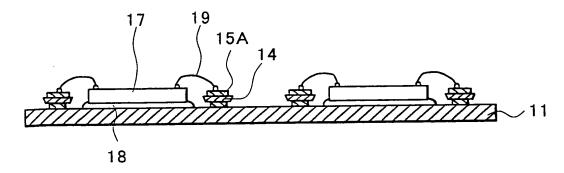
## FIG.4



## FIG.5



## FIG.6





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FIG.7

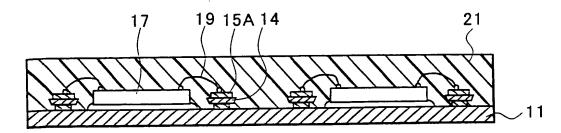


FIG.8

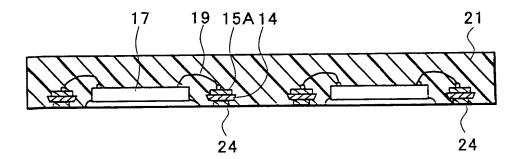
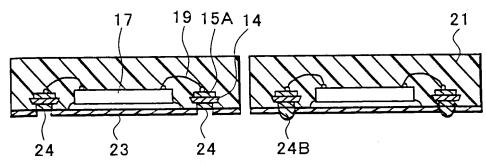


FIG.9





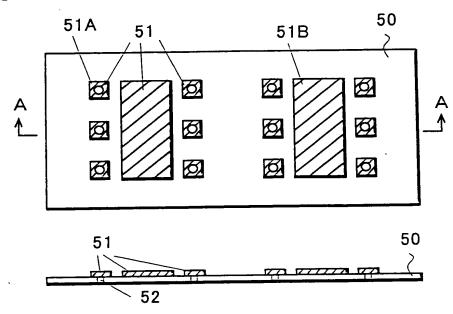
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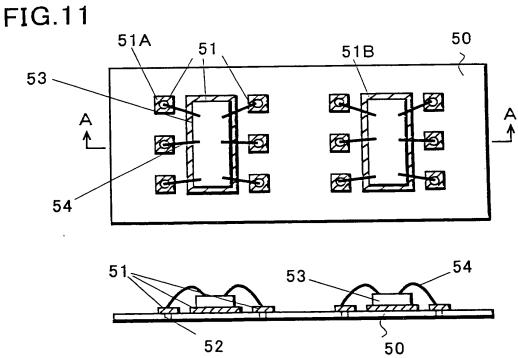
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FIG. 10





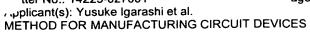






FIG.12A

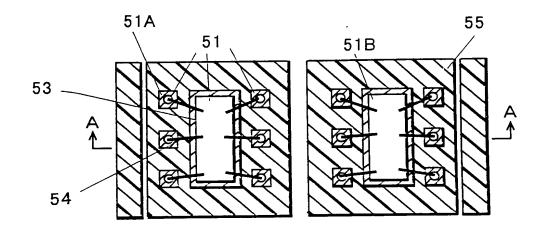


FIG.12B

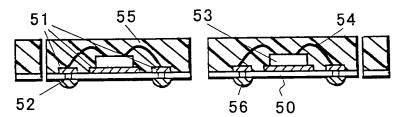
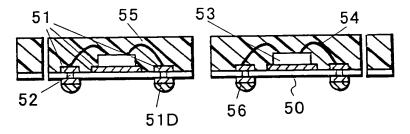


FIG.12C



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FIG.13

